



TSMC-02-1031

March 9, 2004

To: Commissioner for Patents
P.O.Box 1450
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572
28 Davis Avenue
Poughkeepsie, N.Y. 12603

Subject: | Serial No. 10/761,002 01/20/04 |
Wen-Song Tseng et al.
WET BENCH WAFER FLOATING DETECTION
SYSTEM
| _____ |

INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation
In An Application.


The following Patents and/or Publications are submitted to
comply with the duty of disclosure under CFR 1.97-1.99 and
37 CFR 1.56.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first class
mail in an envelope addressed to: Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450, on March 16, 2004.

Stephen B. Ackerman, Reg.# 37761

Signature/Date

 3/16/04

TSMC-02-1031

U.S. Patent 6,033,475 to Hasebe et al., "Resist Processing Apparatus," describes a method of removing bubbles from a developing solution.

U.S. Patent 4,917,123 to McConnell et al., "Apparatus for Treating Wafers with Process Fluids," teaches that a rinsing fluid should be free from bubbles because bubbles trap particles.

U.S. Patent 6,312,597 to Mohindra et al., "Apparatus for Delivering Ultra-Low Particle Counts in Semiconductor Manufacturing," discloses that bubbles can trap particles.

Sincerely,

A handwritten signature in black ink, appearing to read 'S.B. Ackerman', with a stylized flourish at the end.

Stephen B. Ackerman,
Reg. No. 37761

TSMC-02-1031

March 9, 2004

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572
28 Davis Avenue
Poughkeepsie, N.Y. 12603

Subject: | Serial No. 10/761,002 01/20/04 |
Wen-Song Tseng et al.
WET BENCH WAFER FLOATING DETECTION
SYSTEM
| _____ |

ASSOCIATE POWER OF ATTORNEY

I hereby appoint Rosemary L.S. Pike, registration number 39,332, as my associate attorney in this case. Her telephone number is (765) 453-0866.

Please continue to direct all correspondence in this case to the undersigned attorney.

Respectfully submitted,



Stephen B. Ackerman,

Principal attorney of record

Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION.

(Use several sheets if necessary)

Doc No: (Specimen)

Tsmc-02-1031

45460000 Member

10/761,002

Applicant

Applicant: Wen-Song Tseng et al.

Filing Date

01/20/04

Group Art Unit

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (Including Author, Title, Date, Portion or Pages, Etc.)

[illegible]

ОДНУМЪ

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.